



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Masakazu SATO et al.

Group Art Unit: 2812

Application No.: 10/517,655

Docket No.: 122035

Filed: December 13, 2004

For: METHOD OF EVALUATING SHAPE OF SEMICONDUCTOR WAFER AND
APPARATUS FOR EVALUATING SHAPE OF SEMICONDUCTOR WAFER

SECOND REQUEST FOR CORRECTION OF PALM RECORDS

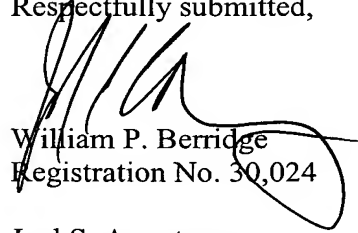
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

A Request for Correction of PALM Records was filed on July 29, 2005. A copy of the Request, a marked-up copy of the Official Filing Receipt and a date stamped receipt is attached hereto.

It is respectfully requested that the Corrected Filing Receipt be immediately forwarded to the attorneys of record at the address set forth below.

Respectfully submitted,


William P. Berridge
Registration No. 30,024

Joel S. Armstrong
Registration No. 36,430

WPB:JSA/sml

Date: July 31, 2006

OLIFF & BERRIDGE, PLC
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Alexandria, Virginia 22320
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REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

William P. Berridge
Registration No. 30,024

Jesse O. Collier
Registration No. 53,839

WPB:JOC/emt

Date: July 29, 2005

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UNITED STATES DEPARTMENT OF COMMERCE
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/517,655	12/13/2004	2812	6600	122035	8	132	2

25944
OLIFF & BERRIDGE, PLC
P.O. BOX 19928
ALEXANDRIA, VA 22320

CONFIRMATION NO. 7281

FILING RECEIPT



OC000000016250423

Date Mailed: 06/13/2005

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Masakazu Sato, Fukushima, JAPAN;
Masato Onishi, Fukushima, JAPAN;

Assignment For Published Patent Application

SHIN-ETSU HANDOTAI CO LTD, Chiyoda-ku, JAPAN

Power of Attorney: The patent practitioners associated with Customer Number 25944.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP03/07320 06/10/2003

Foreign Applications

JAPAN 2002173268 06/11/2002

Projected Publication Date: 09/22/2005

Non-Publication Request: No

Early Publication Request: No

Title

~~Semiconductor wafer shape evaluating method and shape evaluating device~~
 Preliminary Class 438 Method of Evaluating Shape of Semiconductor Wafer and Apparatus for Evaluating Shape of Semiconductor Wafer

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► Mail Room (Regular Delivery)

The following papers have been filed:

Request for Corr. of PALM Records w/mark-up copy OFR

Name of Applicant: Masakazu SATO et al.

Serial No.: 10/517,655

Atty. File No.: 122035

Title (New Cases):

Sender's Initials: WPB/emt

75 / 35

PATENT OFFICE DATE STAMP



41

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AND RETURNED BY MESSENGER**

Oloff & Berridge, PLC
277 S. Washington Street, Suite 500, Alexandria, Virginia 22314